

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fujioka et al.
Appl. No.: Unknown
Conf. No.: Unknown
Filed: January 6, 2006
Title: NITRIDE SEMICONDUCTOR DEVICE AND METHOD FOR
PREPARATION THEREOF
Art Unit: Unknown
Examiner: Unknown
Docket No.: 113184-114

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 37 C.F.R. 1.97, and 37 C.F.R. 1.98, Applicants request that a citation and examination of the references cited below, and on the attached PTO-1449 form be made during the course of examination of the above-identified application for United States patent. Pursuant to 37 C.F.R. 1.98, copies of all foreign patent documents and non-patent documents are enclosed.

U.S. PATENT DOCUMENTS

| <u>Document No.</u> | <u>Date</u> | <u>Inventor</u> |
|---------------------|-------------|-----------------|
| 5,815,520 | 09-28-1998 | Japan |

FOREIGN PATENT DOCUMENTS

| <u>Document No.</u> | <u>Date</u> | <u>Country</u> |
|---------------------|-------------|----------------|
| 08-255932 | 10-01-1996 | Japan |
| 09-045960 | 02-14-1997 | Japan |
| 11-162852 | 06-18-1999 | Japan |
| 2003-328113 | 11-19-2003 | Japan |

Applicants look forward to early and favorable consideration of this matter.

Respectfully submitted,

BY 

Thomas C. Basso
Reg. No.46,541

Dated: January 6, 2006

| | | |
|--|-------------------------------|--|
| INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary) PTO Form 1449 | Atty Docket No. 113184-114 | Application No. 10/563 630 Unknown |
| | Applicant Fujioka et al. | |
| | Filing Date Jan. 6, 2006 | Group Unknown |

| U.S. PATENT DOCUMENTS | | | | | | | |
|------------------------|--|--------------------|---------------------|----------|-------|----------|----------------------------------|
| Examiner's Initials | | Document Number | Publication Date | Inventor | Class | Subclass | Filing Date If Appropriate |
| | | 5,815,520 | 09-28-1998 | Japan | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |
| | | | | | | | |

| FOREIGN PATENT DOCUMENTS | | | | | | | | |
|--------------------------|--|--------------------|---------------------|---------|-------|----------|-------------|----|
| Examiner's Initials | | Document Number | Publication Date | Country | Class | Subclass | Translation | |
| | | | | | | | Yes | No |
| | | 08-255932 | 10-01-1996 | Japan | | | | |
| | | 09-045960 | 02-14-1997 | Japan | | | | |
| | | 11-162852 | 06-18-1999 | Japan | | | | |
| | | 2003-328113 | 11-19-2003 | Japan | | | | |
| | | | | | | | | |
| | | | | | | | | |
| | | | | | | | | |
| | | | | | | | | |

| Examiner's Initials | | OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) |
|------------------------|--|--|
| | | |
| | | |
| | | |
| | | |
| | | |

| | |
|--|------------------|
| Examiner: | Date Considered: |
| *Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |